Image

03560.002983

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)		
	:	Examiner:	Steven H. Versteep
HIROSHI ECHIZEN ET AL.)		
	:	Group Art Unit: 1753	
Application No.: 10/050,787)		
	:		
Filed: January 18, 2002)		
	:		
For: SPUTTERING METHOD AND)		
SPUTTERING APPARATUS		March 26	2004

Mail Stop Non-Fee Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT

Sir:

a) <u>Introductory Comments</u>:

In response to the Office Action dated January 21, 2004, kindly amend the above-identified application as follows: